



中华人民共和国国家知识产权局

State Intellectual Property Office
of the People's Republic of China

Quality and Efficiency: Patent Examination Management

State Intellectual Property Office
of P.R.China

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SIPO's Measures

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**Common Examination Practice Rules
and Quality Management (CEPRQM)**

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**Common Statistical Parameters
for Examination (CSPE)**



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Summary

**SIPO's
Measures**

**Common
Examination
Practice Rules
and Quality
Management**

**Common
Statistical
Parameters
for
Examination**

**Enhancing Quality and Efficiency of
Patent Examination**



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SIPO's Measures





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Common Examination Practice Rules and Quality Management

Examination
Practice
Rules

**Quality
Manage-
ment**

Facilitate users

Enhance mutual
trust

Contribute to
work-sharing



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Common Examination Practice Rules and Quality Management





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**Common Statistical Parameters
for Examination (CSPE)**



CSPE : Background

Existing Parameters

Definition of existing statistical parameters for examination differs among IP5

Inadequacy of statistical parameters for examination with regard to work-sharing



Disadvantages

Pendency	
First	Introduce difficulties to understand the quality and efficiency of each office
Examination	
Request for examination	
KIPO	
Disadvantageous to providing data information for work-sharing	
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CSPE : Summary

Vision

**Form common statistical parameters for examination within IP5.
Exchange IP5 examination practice information under the common rules and with the same parameters.**

Common Statistical Parameters for Examination

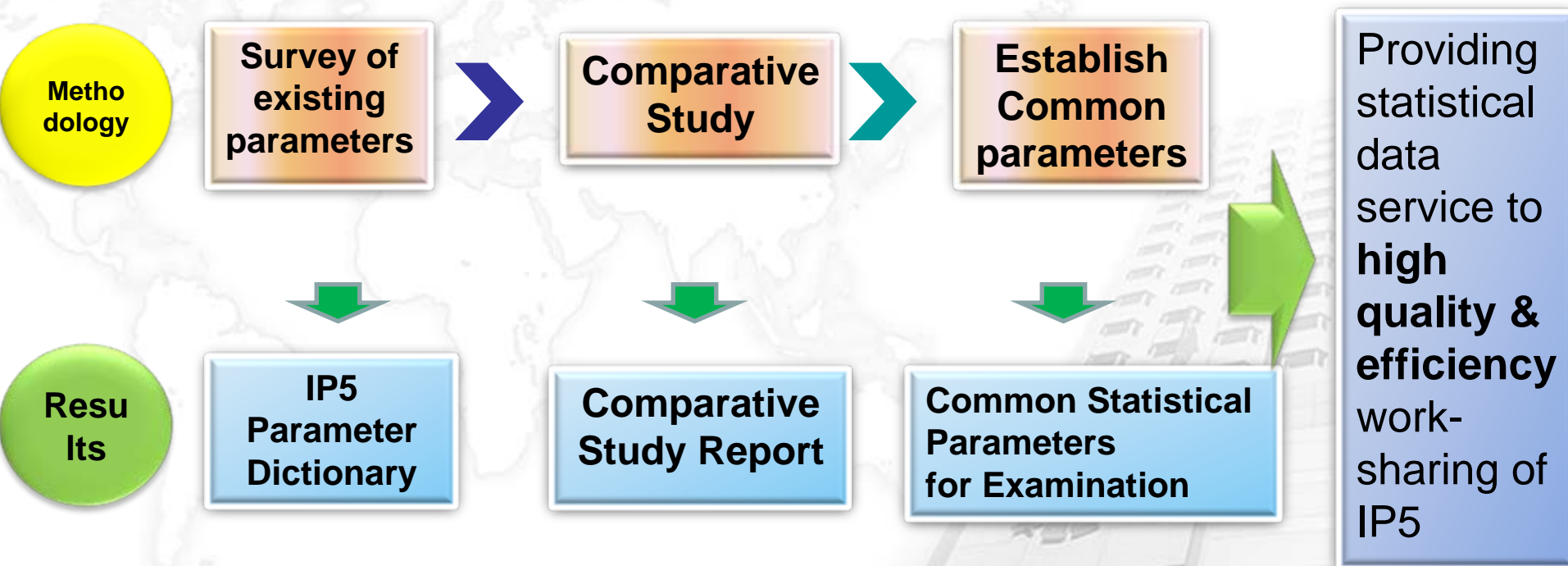
Benefits

Enhance communication and mutual trust

Promote work-sharing



CSPE : Methodology & Results





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THANK YOU